

Approved for entry IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

7/31/09

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**Response Under 37 C.F.R. § 1.116 Expedited Procedure**

**In re application of:** Kenji Suzuki

**Application No.** 10/556,712

**Filed:** November 9, 2005

**Confirmation No.** 6606

**For:** ILLUMINATION OPTICAL SYSTEM,  
PROJECTION/EXPOSURE DEVICE,  
MICRO DEVICE MANUFACTURING  
METHOD, ILLUMINATION DEVICE  
MANUFACTURING METHOD,  
PROJECTION/EXPOSURE DEVICE  
ADJUSTMENT METHOD, AND  
PROJECTION/EXPOSURE DEVICE  
MANUFACTURING METHOD

**Examiner:** Hung Nguyen

**Art Unit:** 2851

**Attorney Reference No.** 4641-71773-01

**FILED VIA EFS  
ON JULY 28, 2009**

COMMISSIONER FOR PATENTS  
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**REPLY TO FINAL OFFICE ACTION, INCLUDING  
APPLICANT'S INTERVIEW SUMMARIES**

This paper is submitted in reply to the final Office action dated June 1, 2009.

Remarks begin on page 2.